

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Yeo, <i>et al.</i>	Docket No.:	TSM03-0760
Serial No.:	10/803,712	Art Unit:	1756
Filed:	March 18, 2004	Examiner:	Brittany L. Raymond
For:	Immersion Fluid for Immersion Lithography, and Method of Performing Immersion Lithography		

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed May 2, 2007. Please amend the above-referenced application as follows.